

Search Notes

Application No.

09/990,948

Examiner

Victor V Yevsikov

Applicant(s)

WU ET AL.

Art Unit

2825

SEARCHED

Class	Subclass	Date	Examiner
438	634,624 638,637 738,783	2/13/2004	VY
438	694,695	2/13/2004	VY
438	697,699	2/13/2004	VY
438	756,780	2/13/2004	VY

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
All as above		2/13/2004	VY

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
((chemical adj mechanical adj polishing) or CMP) and ((first adj conduct\$4 adj layer) with (dielectric adj layer) with substr	2/13/2004	VY
((((chemical adj mechanical adj polishing) or CMP) and ((first adj conduct\$4 adj layer) with (dielectric adj layer) with subst	2/13/2004	VY